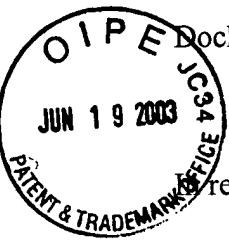


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7/15/03  
PATENT ✓



Docket No.: 60188-447

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of :  
Tomofumi SHONO, et al. :  
Serial No.: 09/987,004 : Group Art Unit: 2823  
Filed: November 13, 2001 : Examiner: Brook Kebede  
For: METHOD FOR FABRICATING ORGANIC THIN FILM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Serial No. 09/987,447

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



Lawrence T. Cullen  
Registration No. 44,489

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202) 756-8000 LTC:MWE  
Facsimile: (202) 756-8087  
**Date: June 19, 2003**